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August 14, 2003

Mail Stop Non-Fee Amendment
Commissioner For Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Re: Applicant(s): Woo Sik Yoo
Assignee: WaferMasters, Inc.
Title: Method for H2 Recycling In Semiconductor Processing System
Serial No.: 09/828,518
Examiner: Olivia T. Luk
Docket No.: M-8608US
Filed: April 6, 2001
Group Art Unit: 2812

Dear Sir:

Transmitted herewith are the following documents in the above-identified application:

- (1) Return Receipt Postcard;
- (2) This Transmittal Letter (in duplicate);
- (3) Response to Office Action (7 pages).

- ☒ No additional fee is required.
☐ The fee has been calculated as shown below:

CLAIMS AS AMENDED

	Claims Remaining <u>After Amendment</u>		Highest No. Previously <u>Paid For</u>		Present <u>Extra</u>	<u>Rate</u>	Additional <u>Fee</u>
Total Claims	14	Minus	20	=	0	x \$18.00	\$ 0
Independent Claims	3	Minus	3	=	0	x \$84.00	\$ 0
<input type="checkbox"/> Fee for Request for Extension of Time							\$

Total additional fee for this Amendment:

\$

- ☐ Conditional Petition for Extension of Time: If an extension of time is required for timely filing of the enclosed document(s) after all papers filed with this transmittal have been considered, an extension of time is hereby requested.
- ☐ Please charge our Deposit Account No. 50-2257 in the amount of \$
- ☒ Also, charge any additional fees required and credit any overpayment to our Deposit Account No. 50-2257

Total: \$ 0

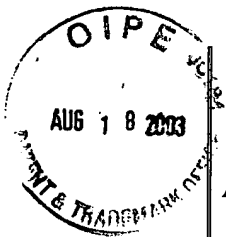
I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231, on August 14, 2003.

Sandy Kim

August 14, 2003
Date of Signature

Respectfully submitted,

Theodore P. Lopez
Attorney for Applicants
Reg. No. 44,881



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Yoo, Woo Sik
Assignee: WaferMasters, Inc.
Title: Method for H₂ Recycling in a Semiconductor Processing System
Serial No.: 09/828,518 Filing Date: April 6, 2001
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Irvine, California
August 14, 2003

Mail Stop Amendment
COMMISSIONER FOR PATENTS
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO OFFICE ACTION

Dear Sir:

In response to the Office Action dated May 15, 2003, Applicants submit the following amendments and remarks.